

APPLICATION No.
09/933,819

FILING DATE
August 22, 2001

GROUP
2121

OIP
OCT 07 2002
PATENT & TRADEMARK OFFICE

Examiner Initials	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication (MM-DD-YYYY)
	Number	Kind Code (if known)		
TM	4,648,034		Heninger	03-03-1987
TM	5,870,602		Miller et al.	02-09-1999
TM	5,430,850		Papadopoulos et al.	07-04-1995
TM	4,860,191		Nomura et al.	08-22-1989
TM	4,829,420		Stähle	05-09-1989
TM	4,395,758		Helenius et al.	07-26-1983

Examiner Initials	Foreign Patent Document		Country	Date of Publication (MM-DD-YYYY)	Translation	
	Number	Kind Code (if known)			Yes	no
TM	2 225 881	A	Great Britain	06-13-1990		
TM	0 588 341	A2	EPO	03-23-1994		
TM	95/19006		WIPO	07-13-1995		
TM	01/44964	A2	WIPO	06-21-2001		
TM	2 230 119	A	Great Britain	10-10-1990		
TM	0 671 685	A2	EPO	09-13-1995		
TM	0 628 917	A2	EPO	06-09-1994		

Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	U.S. Patent Application No. 10/175,446 "DATA PROCESSING SYSTEM AND CONTROL METHOD"		
	U.S. Patent Application No. 10/175,447 "DATA PROCESSING SYSTEM AND CONTROL METHOD"		
	U.S. Patent Application No. 10/174,750 "DATA PROCESSING SYSTEM AND CONTROL METHOD"		
Examiner Signature	<i>Tina Meade</i>	Date Considered	<i>June 3, 2004</i>

(05/01)



SHEET 1 OF 1

Substitute for forms 1449A/PTO & 1449B/PTO

THIRD INFORMATION DISCLOSURE
STATEMENT BY APPLICANTATTORNEY'S DKT NO.
032865-012APPLICATION NO.
09/933,819APPLICANT
Shoichi KAMANO et al.FILING DATE
August 22, 2001GROUP
2121

U.S. PATENT DOCUMENTS				
Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
TM	5,450,553		Kitagaki et al.	09-12-1995
TM	5,487,173		Greiss et al.	01-23-1996
TM	5,903,744		Tseng et al.	05-11-1999
TM	5,495,558		Gibart et al.	02-27-1996
TM	5,894,582		Yoshida et al.	04-13-1999
				RECEIVED
				MAR 17 2003
				Technology Center 2100

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	Translation Yes No
TM	2000-112585		Japan	04-21-2000	X
TM	2 232 514	A	Great Britain	12-12-1990	
TM	0 174 231	A1	EPO	03-12-1986	

NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	U.S. Patent Application No. 10/320,622 "DATA PROCESSING SYSTEM"
	U.S. Patent Application No. 10/109,650 "DATA PROCESSING SYSTEM AND DESIGN SYSTEM"

Examiner Signature	<i>Denise M. Lemsky</i>	Date Considered	<i>June 3, 2004</i>
--------------------	-------------------------	-----------------	---------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

Substitute for form 1449A/PTO

ATTORNEY'S DKT NO.
032865-012

APPLICATION NO.
09/933,819

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICANT
Shoichi KAMANO et al.

FILING DATE
August 22, 2001

GROUP
2121



U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	U.S. Patent Application No. 09/860,563		
	U.S. Patent Application No. 09/985,987		
	U.S. Patent Application No. 10/053,737		
Examiner Signature			
Examiner Signature	Tania M. Moseke		Date Considered
			June 3, 2004

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.